



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 7, 2026

IGI Report Number

LG842617862

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED OCTAGONAL STEP CUT

Measurements

9.50 X 7.10 X 3.34 MM

GRADING RESULTS

Carat Weight

1.62 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

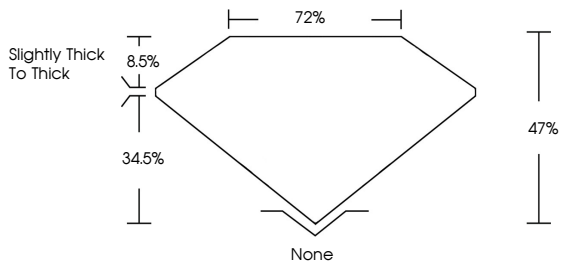
Inscription(s)

 LG842617862

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



Slightly Thick To Thick

72%

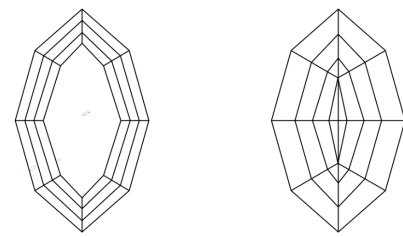
8.5%

34.5%

47%

None

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



Sample Image Used

IGI



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VVS 2

Table

47%

Girdle

72%

Slightly Thick To Thick

Culet

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Fluorescence

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